

<b>Notice of References Cited</b>	Application/Control No. 10/800,630	Applicant(s)/Patent Under Reexamination TASHIRO ET AL.	
	Examiner Andy Huynh	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,020,634	02-2000	Gerber et al.	257/726
	C	US-			
	D	US-			
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	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	JP 2001015237 A	01-2001	Japan	OKUDA et al.	
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	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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